



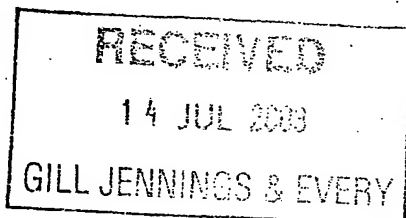
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DIARIED

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Anmeldung Nr./Application No./Demande n°/Patent Nr./Patent No./Brevet n°.

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Anmelder/Applicant/Demandeur/Patentinhaber/Propriétaire/Titulaire

SensoNor asa

COMMUNICATION

The European Patent Office herewith transmits as an enclosure the European search report for the above-mentioned European patent application.

If applicable, copies of the documents cited in the European search report are attached.

☒ Additional set(s) of copies of the documents cited in the European search report is (are) enclosed as well.

The following specifications given by the applicant have been approved by the Search Division:

☒ abstract

☒ title

☐ The abstract was modified by the Search Division and the definitive text is attached to this communication.

The following figure will be published together with the abstract:

NONE

REFUND OF THE SEARCH FEE

If applicable under Article 10 Rules relating to fees, a separate communication from the Receiving Section on the refund of the search fee will be sent later.





DOCUMENTS CONSIDERED TO BE RELEVANT															
Category	Citation of document with indication, where appropriate, of relevant passages	Relevant to claim	CLASSIFICATION OF THE APPLICATION (Int.Cl.7)												
X	LAPADATU D ET AL: "Building of silicon mechanical sensors by bulk micromachining and anodic bonding" 1998 INTERNATIONAL SEMICONDUCTOR CONFERENCE. CAS'98 PROCEEDINGS (CAT. NO.98TH8351), 1998 INTERNATIONAL SEMICONDUCTOR CONFERENCE. CAS'98 PROCEEDINGS, SINAIA, ROMANIA, 6-10 OCT. 1998, pages 33-44 vol.1, XP010313805 1998, New York, NY, USA, IEEE, USA ISBN: 0-7803-4432-4 * figures 7-9 * * paragraphs '03.2!, '03.3!, '04.1!-'04.4! *	1-5, 7-15, 17-19	B81B7/00												
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D, X	CHAVAN A V ET AL: "A MONOLITHIC FULLY-INTEGRATED VACUUM-SEALED CMOS PRESSURE SENSOR" PROCEEDINGS OF THE IEEE 13TH. ANNUAL INTERNATIONAL CONFERENCE ON MICRO ELECTRO MECHANICAL SYSTEMS. MEMS 2000. MIYAZAKI, JAPAN, JAN. 23-27, 2000, IEEE INTERNATIONAL MICRO ELECTRO MECHANICAL SYSTEMS CONFERENCE, NEW YORK, NY: IEEE, US, 23 January 2000 (2000-01-23), pages 341-346, XP001045339 ISBN: 0-7803-5274-2 * figures 1,2,6-8 * * paragraphs 'STRUCTURAL!', '!', 'PROCESS!' *	1-8, 10-18													
A	----- -/--	9, 19													
The present search report has been drawn up for all claims															
Place of search BERLIN		Date of completion of the search 3 July 2003	Examiner Polesello, P												
<table border="0"><tr><td>CATEGORY OF CITED DOCUMENTS</td><td>T : theory or principle underlying the invention</td></tr><tr><td>X : particularly relevant if taken alone</td><td>E : earlier patent document, but published on, or</td></tr><tr><td>Y : particularly relevant if combined with another document of the same category</td><td>after the filing date</td></tr><tr><td>A : technological background</td><td>D : document cited in the application</td></tr><tr><td>O : non-written disclosure</td><td>L : document cited for other reasons</td></tr><tr><td>P : intermediate document</td><td>& : member of the same patent family, corresponding document</td></tr></table>				CATEGORY OF CITED DOCUMENTS	T : theory or principle underlying the invention	X : particularly relevant if taken alone	E : earlier patent document, but published on, or	Y : particularly relevant if combined with another document of the same category	after the filing date	A : technological background	D : document cited in the application	O : non-written disclosure	L : document cited for other reasons	P : intermediate document	& : member of the same patent family, corresponding document
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EPO FORM 1503 03.02 (P04C01)



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ANNEX TO THE EUROPEAN PATENT APPLICATION NO.

EP 03 25 1626

This annex lists the patent family members relating to the patent documents cited in the above-mentioned European search report. The members are as contained in the European Patent Office EDP file on
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